



IFW

PATENT
8070-1003

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Tatsuya SUZUKI et al.

Conf.: 7159

Appl. No.: 10/685,571

Group: 2812

Filed: October 16, 2003

Examiner: W.Lindsay, Jr.

METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 30, 2004

Sir:

In response to the Office Action mailed November 1, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.